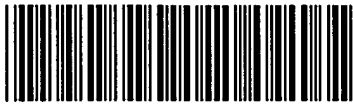


**Search Notes**

Application/Control No.

10/742,326

Examiner

Justin Krause

Applicant(s)/Patent under  
Reexamination

KIM, TAE IK

Art Unit

3682

**SEARCHED**

Class	Subclass	Date	Examiner
74	572.2 573.1 574.2 5R 571.11	12/8/2005	JMK
74	570-574		

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
PG Pubs interference		12/9/2005	

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
See East History	12/8/2005	JMK
74 search - C. Kim and R. Bonck		
Plus Search		